

QCO.091A



PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wen-Jian Lin
Appl. No. : 10/810,660
Filed : March 29, 2004
For : STRUCTURE OF A MICRO
ELECTRO MECHANICAL
SYSTEM AND THE
MANUFACTURING METHOD
THEREOF
Examiner : Jarrett J. Stark
Group Art Unit : 2823

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

September 6, 2006

(Date)

Ryan E. Melnick

Ryan E. Melnick, Reg. No. 58,621

AMENDMENT

Mail Stop RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed June 6, 2006, please find the enclosed amendments and remarks. This response is a submission under 37 CFR § 1.114(a) and is being accompanied by a Request for Continued Examination.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Summary of Interview begins on page 9 of this paper.

Remarks/Arguments begin on page 10 of this paper.